



BUCKET NO.: 0039-7669-2S

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF

EIJI SAWA ET AL.

SERIAL NO: 09/538,398

FILED: MARCH 29, 2000

FOR: METHOD AND APPARATUS FOR  
INSPECTING PATTERNS

:

: EXAMINER: PATEL, S.

:

: GROUP ART UNIT: 2621

:

**RECEIVED**

APR 18 2003

Technology Center 2600

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action of January 15, 2003, please amend the above-identified application as follows:

IN THE SPECIFICATION

Please amend the specification as indicated below.<sup>1</sup>

✓  
Please insert the following heading at page 1, between lines 9 and 10:

FIELD OF THE INVENTION

✓  
Please insert the following heading at page 1, between lines 26 and 27:

DISCUSSION OF THE BACKGROUND

Please replace the paragraph at page 2, lines 12-17, as follows:

<sup>1</sup> A marked-up copy of the amendments is attached hereto.